

DOCKET NO: 245161US3CIP



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TSUTOMU OKABE, ET AL.

SERIAL NO: 10/706,914

RCE FILED: HEREWITH

FOR: WAFER PROCESSING
APPARATUS HAVING DUST PROOF
FUNCTION

: EXAMINER: MOORE, K.

: GROUP ART UNIT: 1763

: (APPLICATION FILED: NOVEMBER
14, 2003)

*Entered
w/RCE
12/22/05*

AMENDMENT UNDER 37 C.F.R. § 1.114

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 22, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.